

**Official Communication  
PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: Selzer  
 Application No.: 09/876,443  
 Filing Date: June 7, 2001  
 Title: Method of Improving X-Ray  
 Lithography in the Sub 100nm  
 Range to Create High Quality  
 Semiconductor Devices

Docket No. 1520-006 (1426)  
 Date: June 7, 2004  
 Group Art Unit: 2882  
 Examiner: I. Kiknadze  
 FAX: 703 872-9318  
 Pages sent: 1 and 4-14

Corrected Amendment Under 37 CFR 1.111  
 Amendment F'

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Assistant Commissioner of Patents  
 Washington, D.C. 20231

Sir:

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This is in response to the Notice of Non-Compliant Amendment, dated June 4, 2004 and the office action dated February 26, 2004. This corrected amendment includes mention of claims 1-10 as being canceled on page 4. The only section of the amendment herein presented is the section regarding the amendment to the claims as provided in 37 CFR 1.21(h). The entire amendment to the claims is herein presented. If there is any further problem please contact applicant's attorney at 802 864-1575.

**CERTIFICATE OF MAILING**  
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